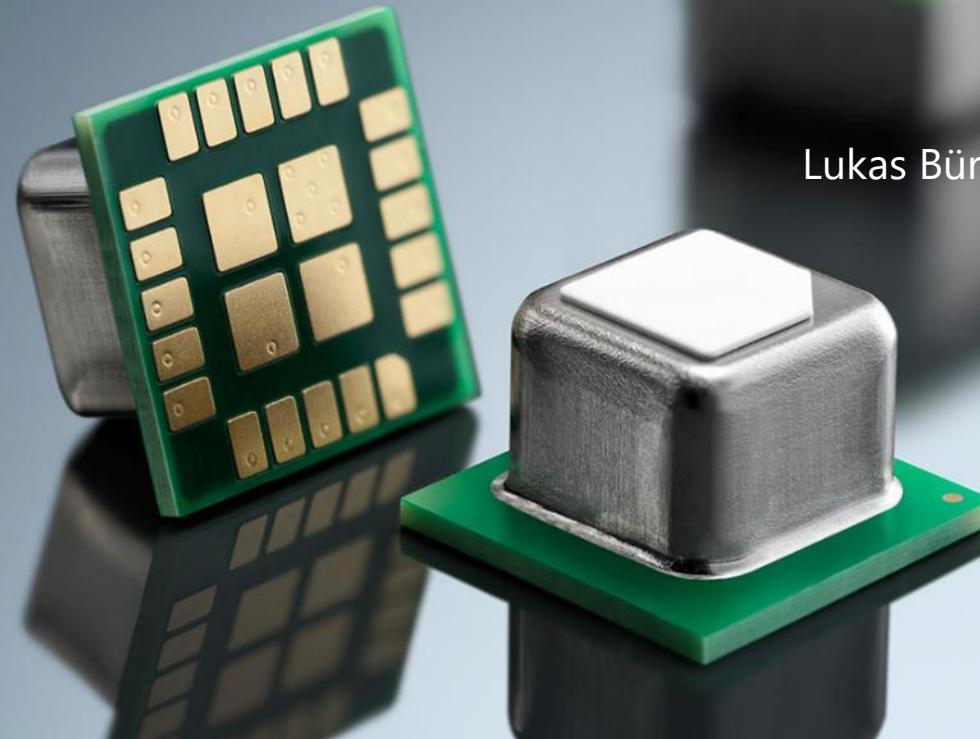


SENSIRION

From ETH Start-Up to global leader in environmental and flow sensing



Lukas Bürgi, Director R&D Sensor Innovations | 25 March 2025

SENSIRION

Speaker CV



Lukas Bürgi

ETH zürich

MSc in Physics

EPFL

PhD in experimental Physics
Electron dynamics and transport at metal surfaces



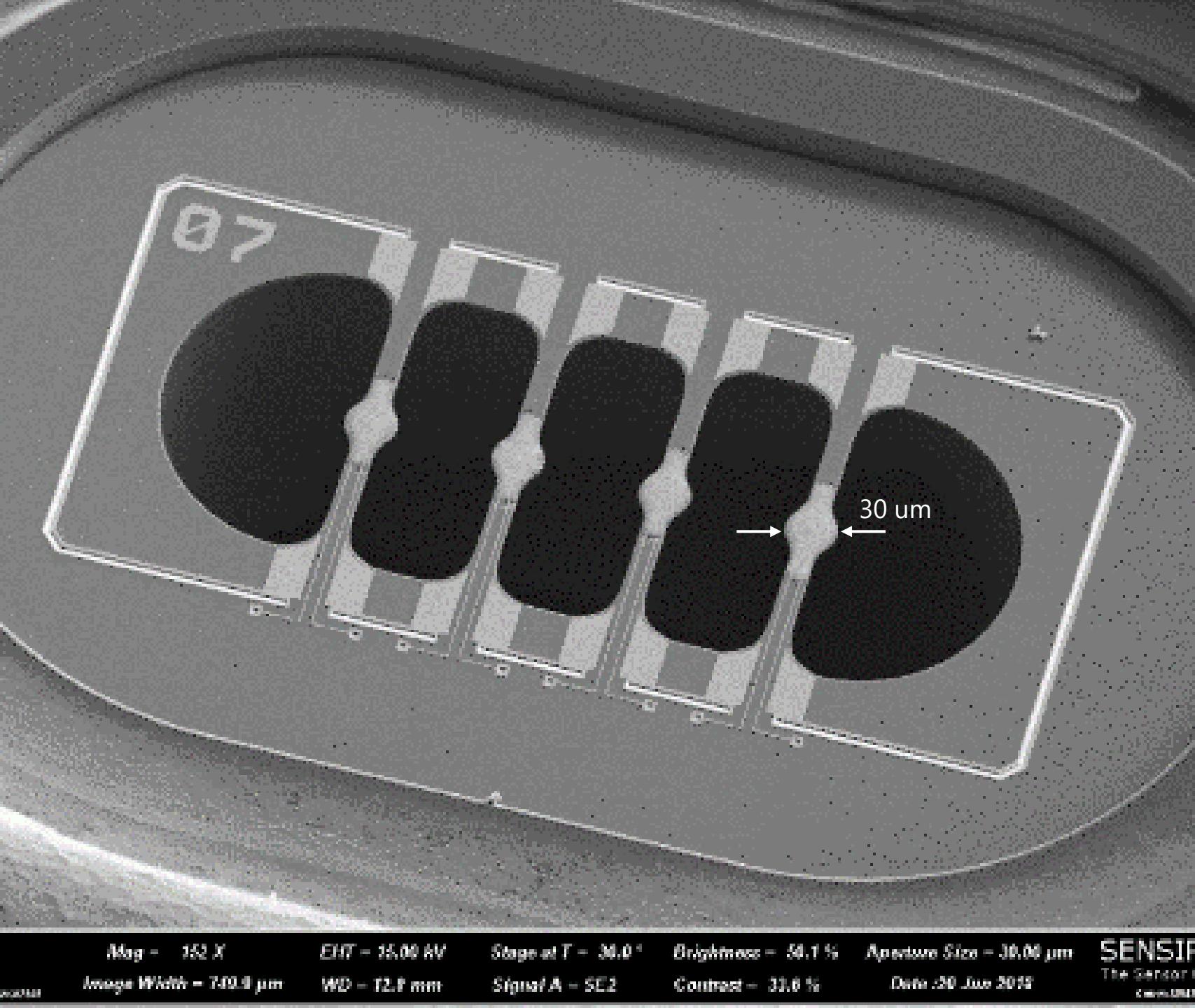
Postdoc
Organic optoelectronics

:: csem

Project Manager & Deputy Section Head
Polymer Optoelectronics, Division Photonics

SENSIRION

2008 - 2012 Project Manager R&D Gasflow
2012 - Today Director R&D Sensor Innovation



The heart of a
Sensirion
microsensor

Mag = 152 X

EHT = 25.00 kV

Stage tilt = 36.0 ° Brightness = 59.1 %

Aperture Size = 30.00 μm

SENSIRION
The Sensor Company

Image Width = 749.0 μm

WD = 12.8 mm

Signal A = SC2

Contrast = 33.6 %

Date: 20 Jun 2014

Agenda

- 1 Sensirion in brief
- 2 Sensirion technology: Some examples
- 3 R&D and innovation in industry



“

We make the difference in sensing
for a better world

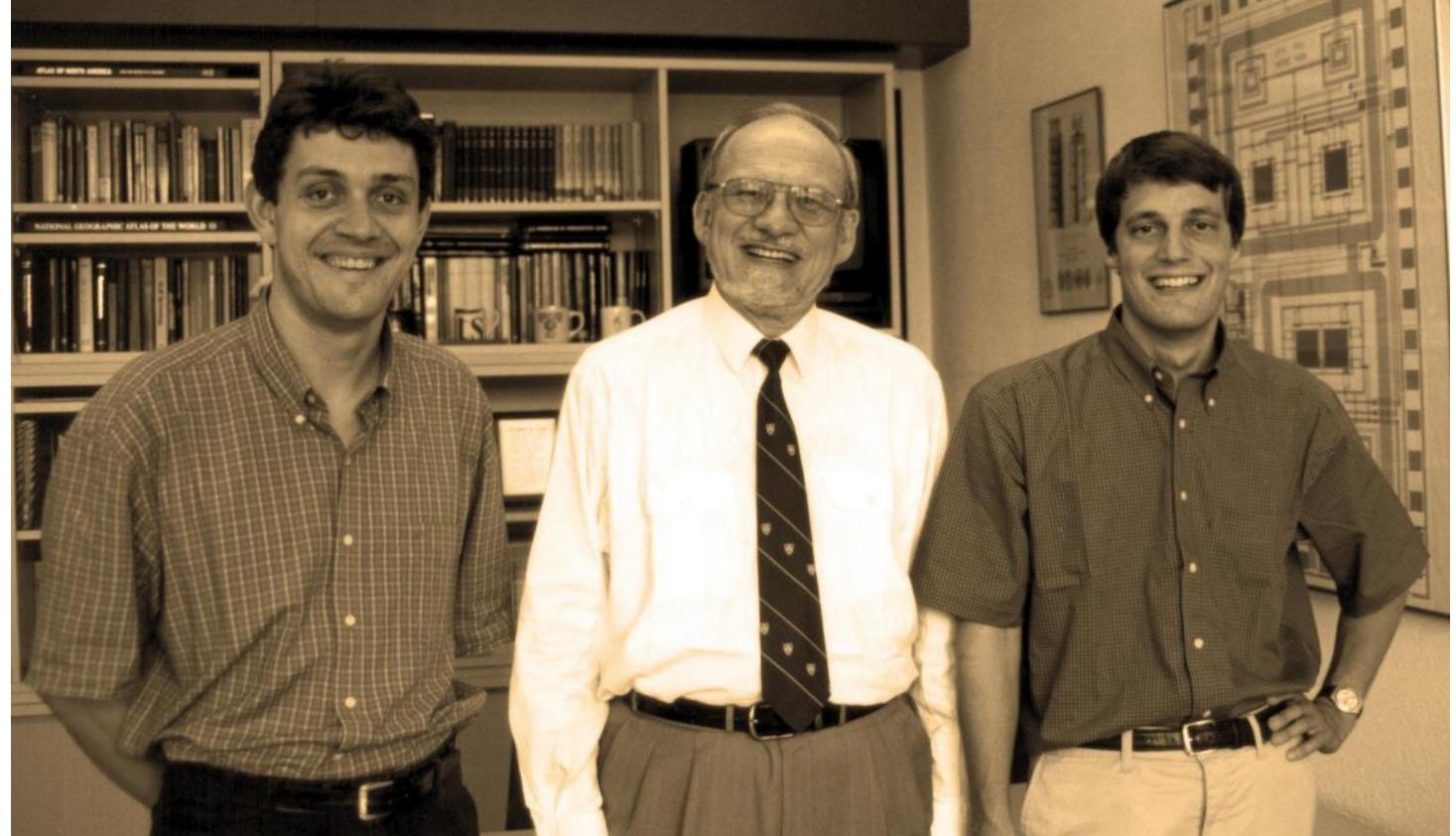
Our Mission Statement

Facts & figures



1998 founded
2018 IPO

ETH Zürich, 1998



Felix Mayer

Prof Henry Baltes

Moritz Lechner

Facts & figures



1998 founded
2018 IPO



1164 ⁽¹⁾
Full-time
equivalents (FTEs)

(1) As of 31st December 2024

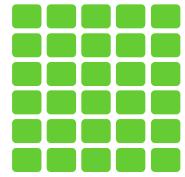
Bregenz 2015



Facts & figures



1998 founded
2018 IPO



~200 Mio
sensors
produced per year



277 M CHF 2024
233 M CHF 2023
Revenue



1164 ⁽¹⁾
Full-time
equivalents (FTEs)



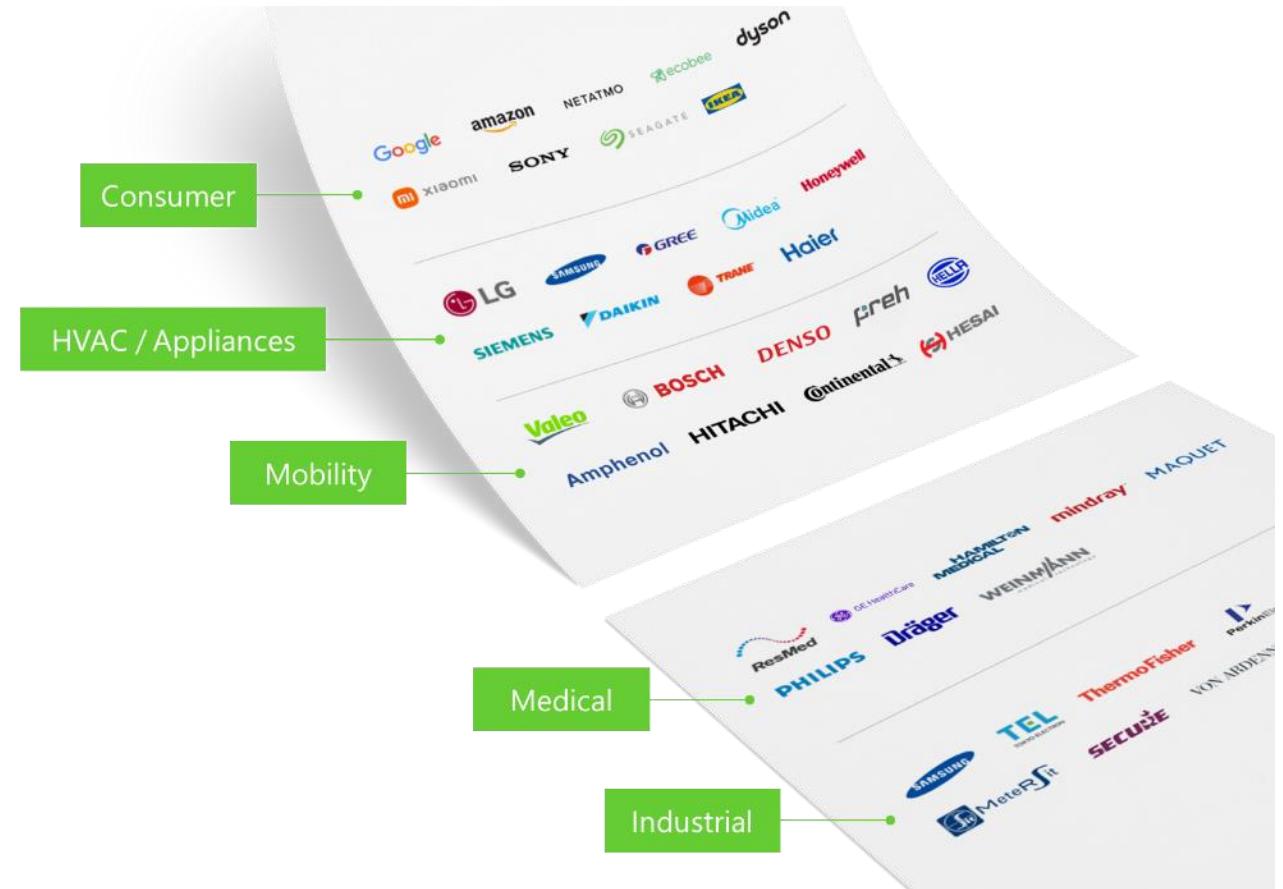
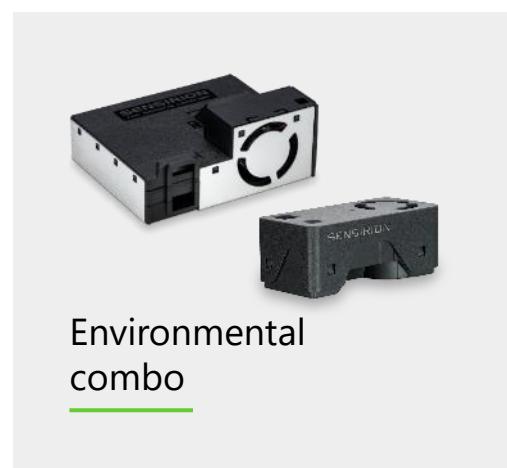
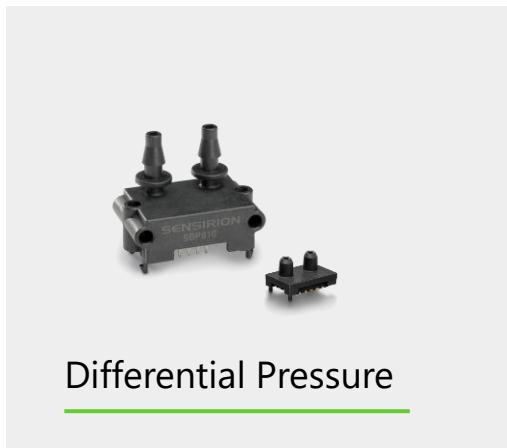
> 200
Patent families



~20%
Of revenue
invested in R&D

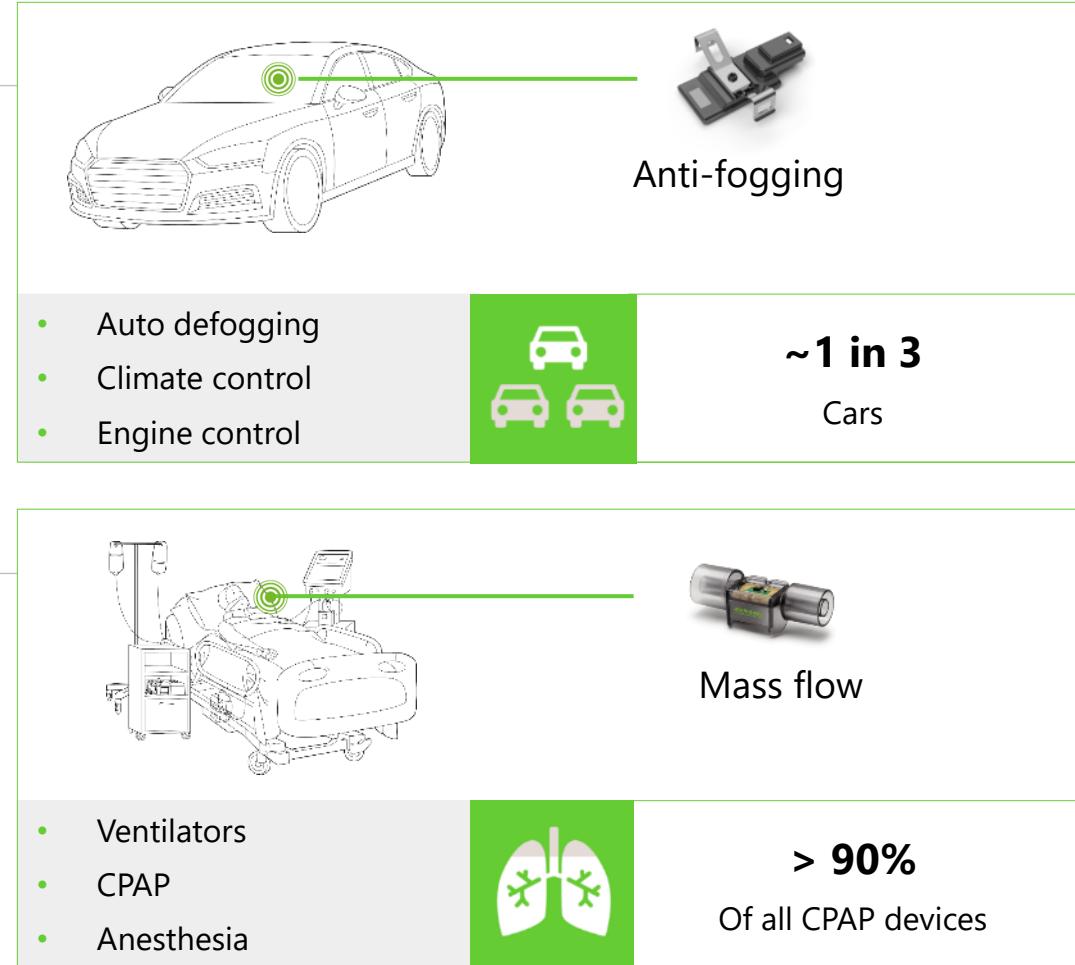
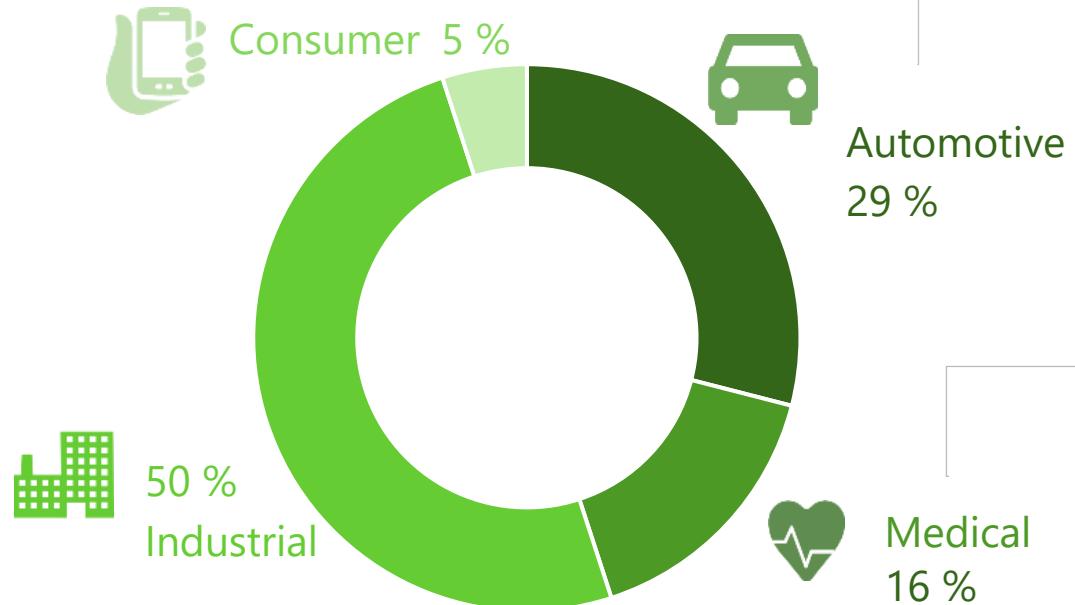
(1) As of 31st December 2024

Versatile products for a broad market and customer base



Our markets and applications

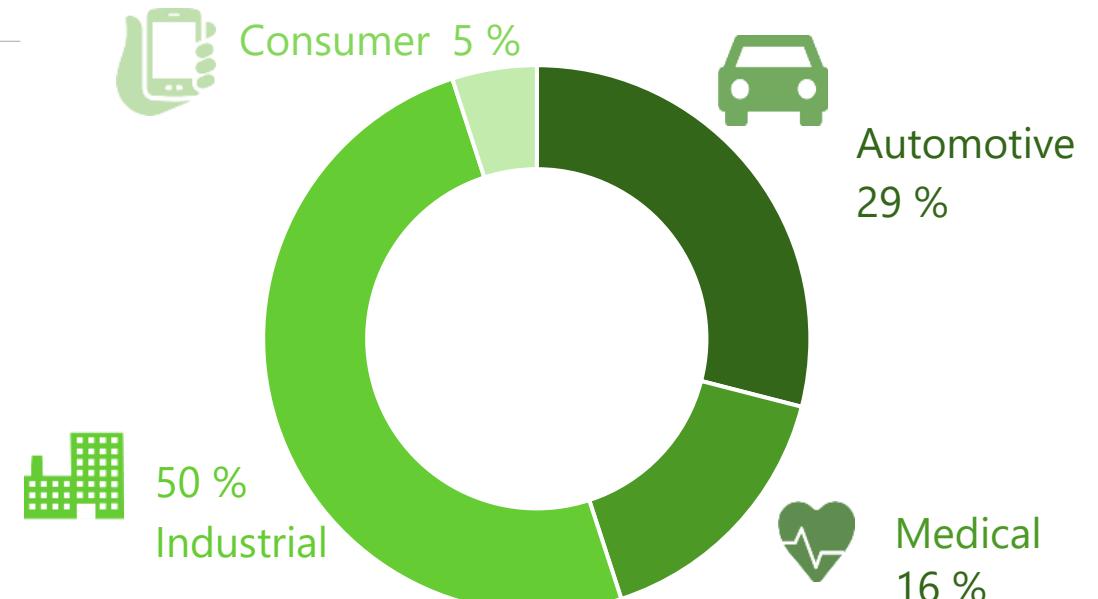
Revenue by Market 2024



Our markets and applications



Revenue by Market 2024



Agenda

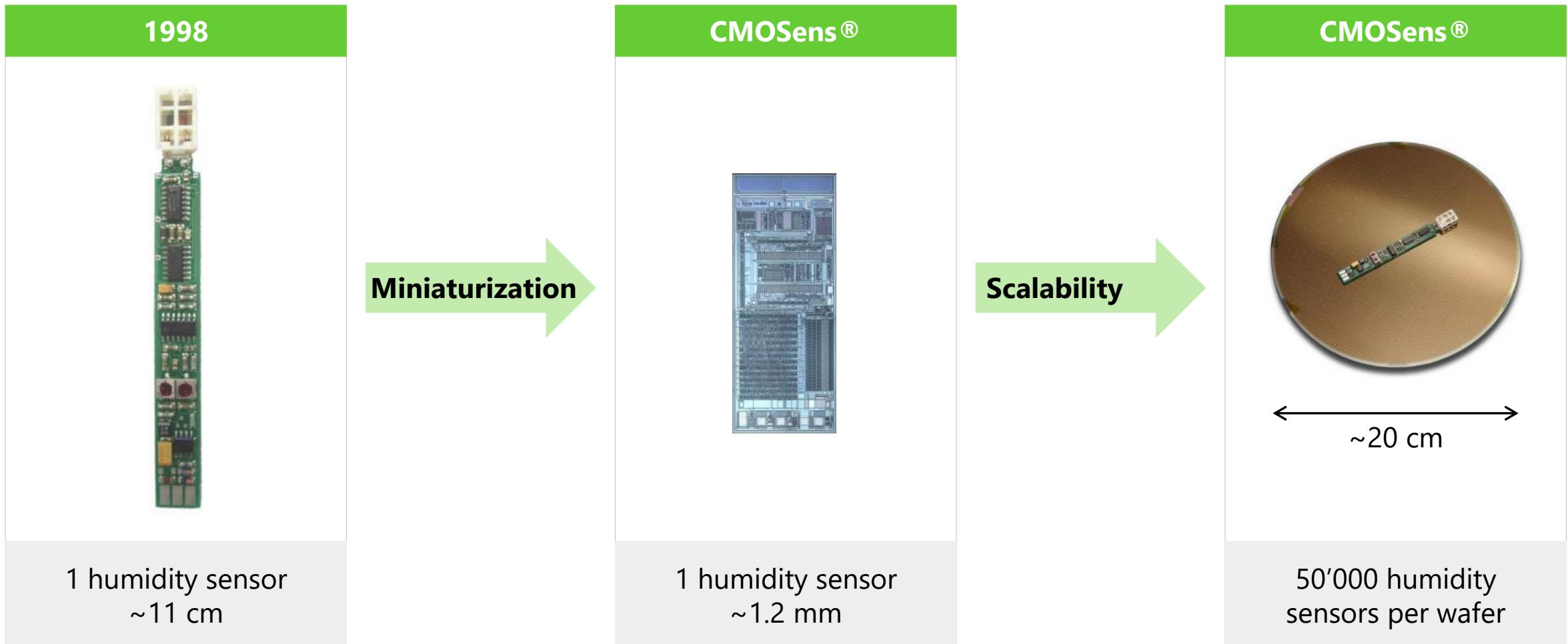
1 Sensirion in brief

2 Sensirion technology: Some examples

3 R&D and innovation in industry



CMOSens® is the heart of Sensirion products



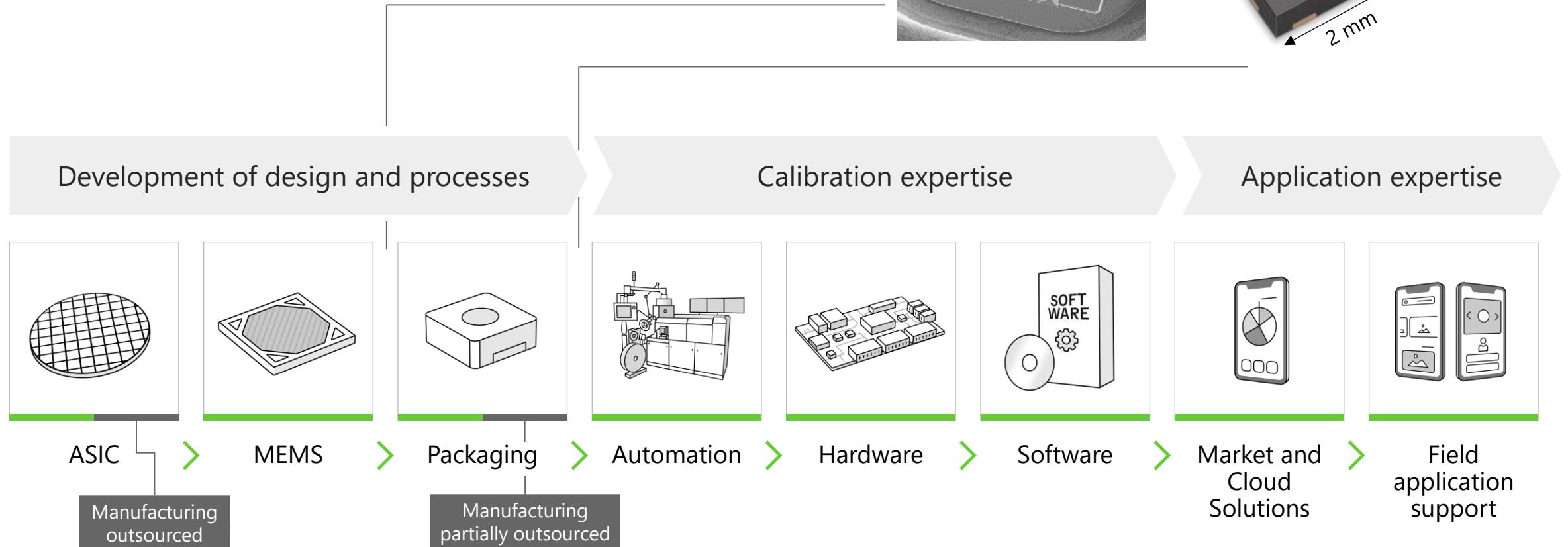
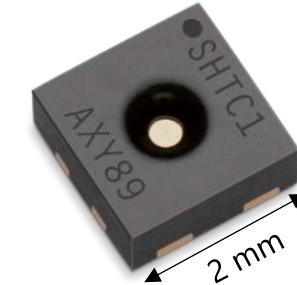
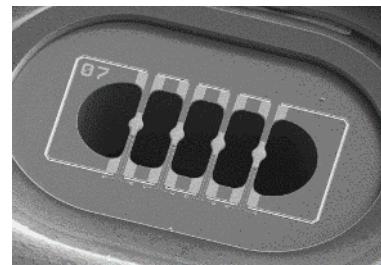


Evolution of humidity & T sensors

200 pcs each of
SHT10 | SHT20 | SHTC3 | SHT40

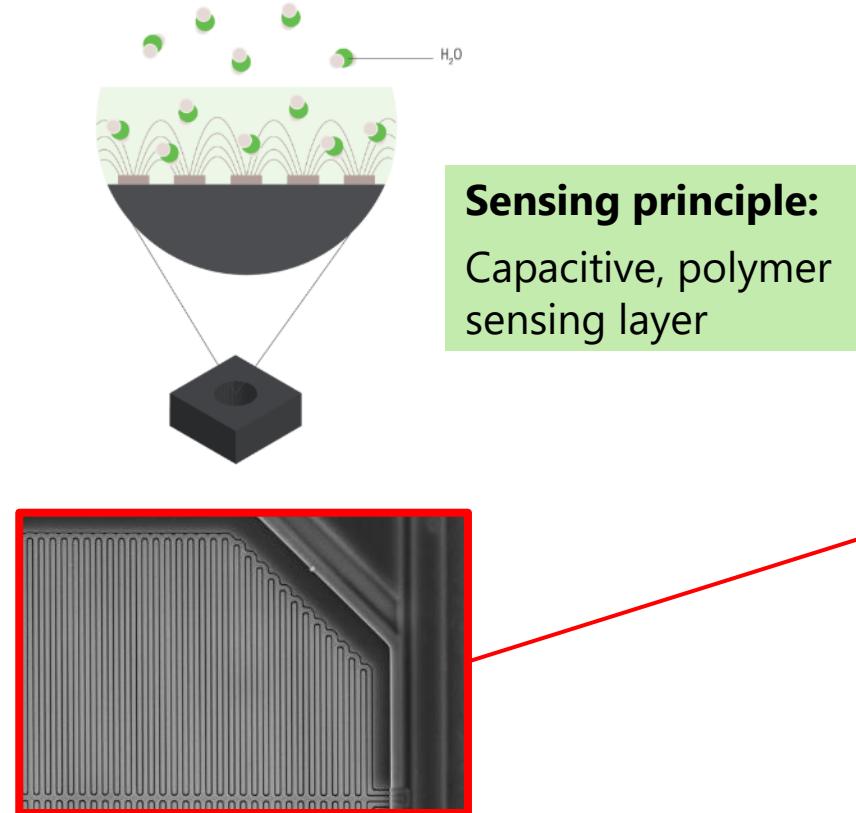
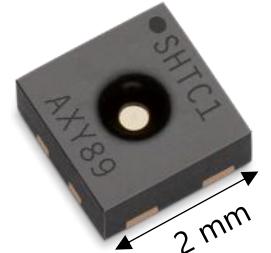
Our competencies for innovation

Automated high-volume production

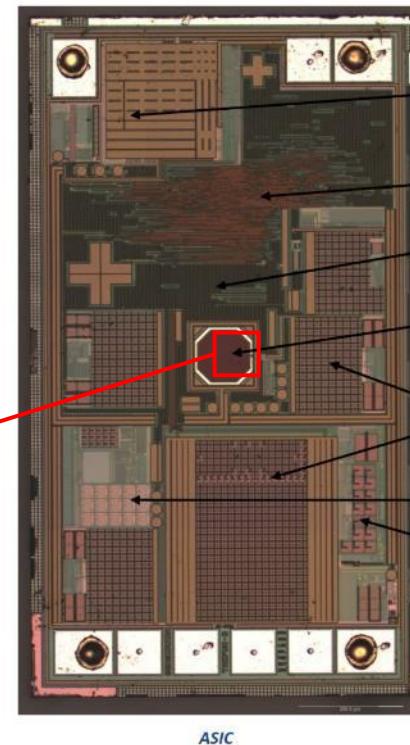


CMOSens example 1: Humidity & temperature sensor

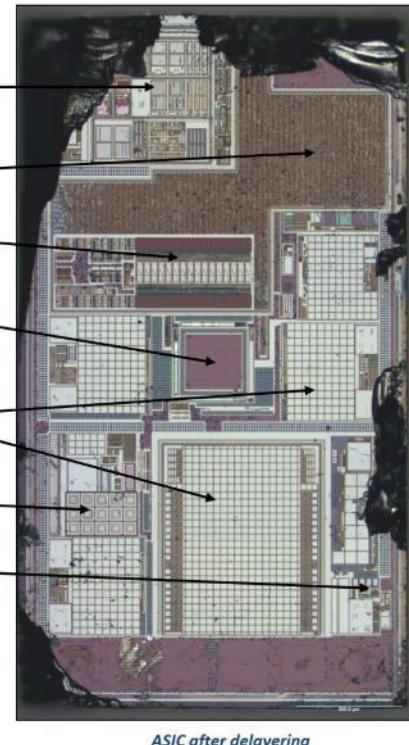
CMOSens = Sensing element & CMOS electronics, monolithic, fully calibrated, digital output



Sensing principle:
Capacitive, polymer
sensing layer



Analog
Logic
Memory
Humidity
sensor
MIM Capacitor
Diodes
Analog

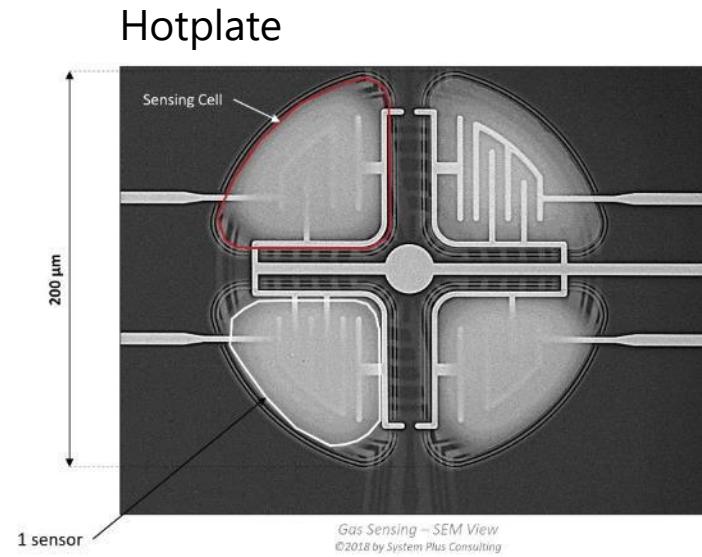
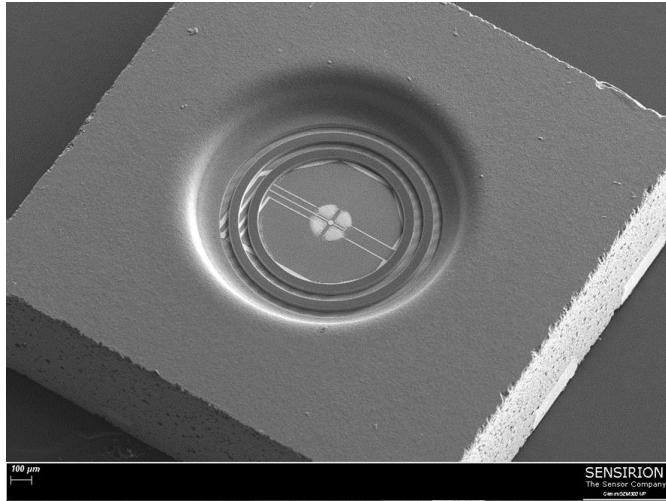


ASIC after delayering

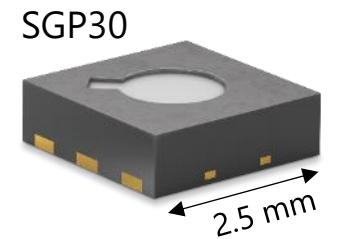
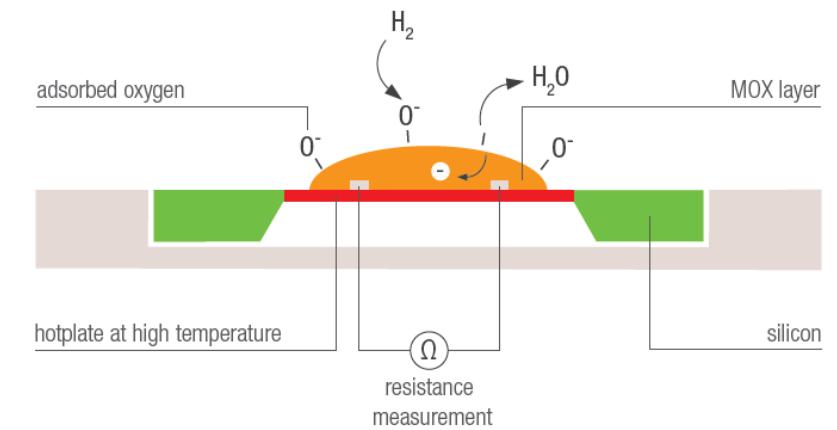
1.3 mm

2 mm

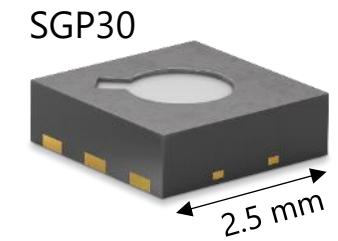
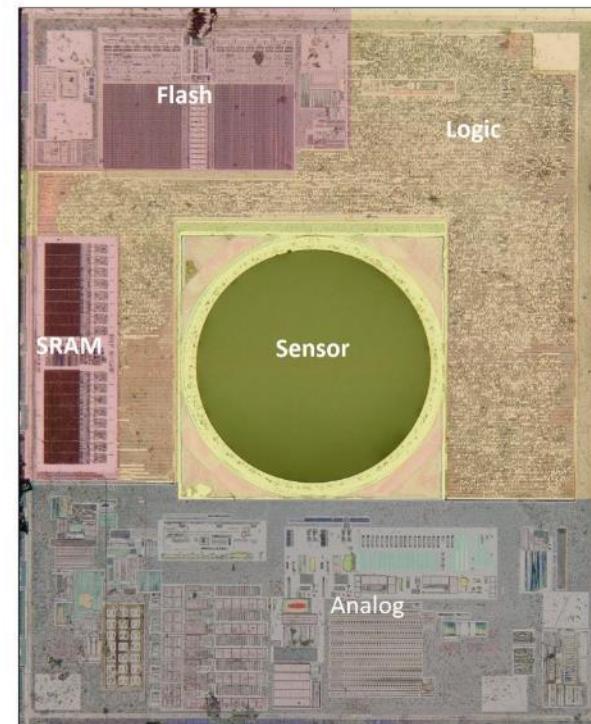
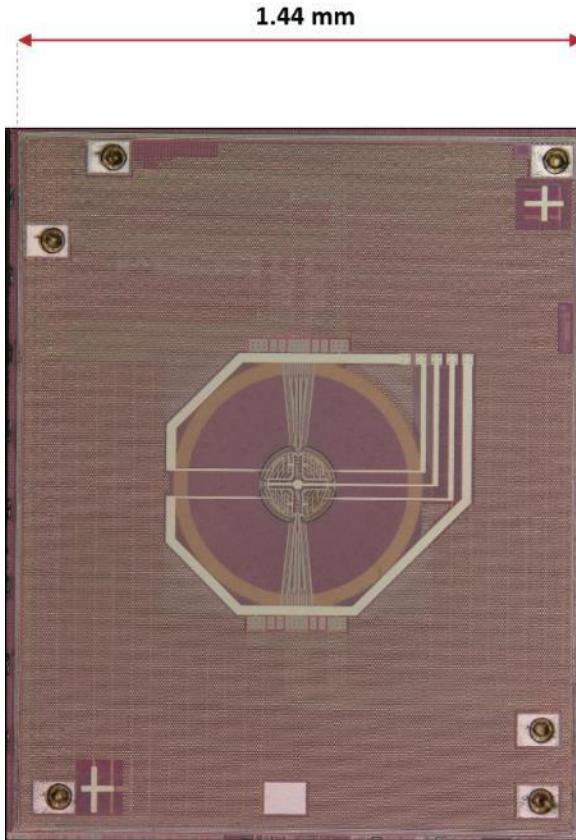
CMOSens example 2: Multi-pixel MOX gas sensor



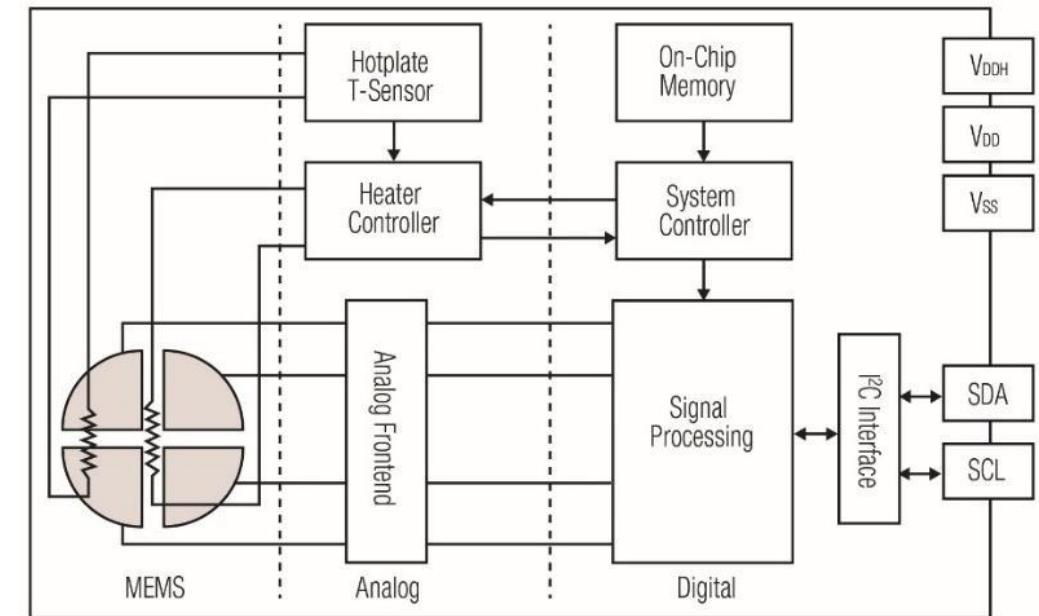
Sensing principle:
Chemoresistive, heated metal-oxide (MOX) sensing layer



CMOSens example 2: Multi-pixel MOX gas sensor

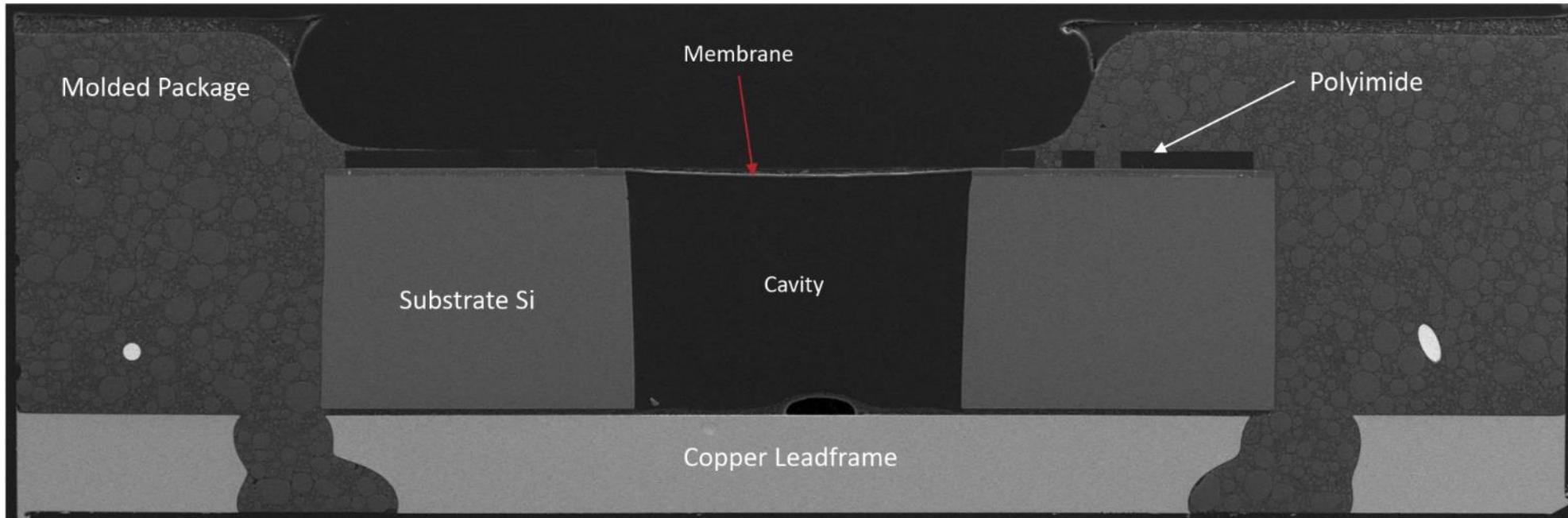
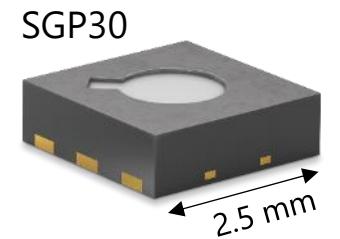


Block diagram SGP30



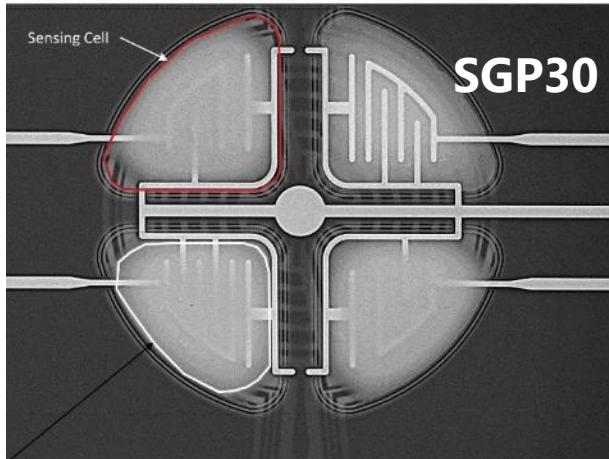
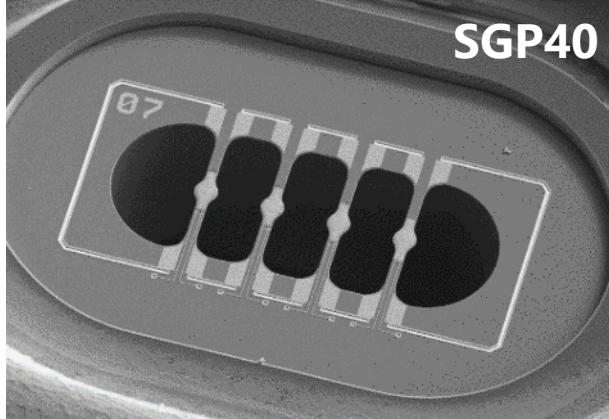
CMOSens example 2: Multi-pixel MOX gas sensor

Main MEMS process: Backside release of membrane by deep reactive-ion etching



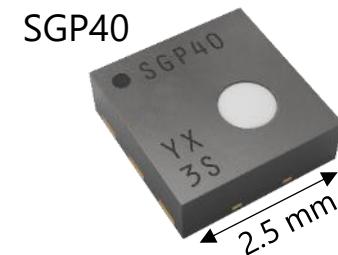
Package: Open-cavity molded, 6-pin DFN (Dual Flat No lead), reflow solderable

CMOSens example 2: Multi-pixel MOX gas sensor



Gas Sensing – SEM View
©2018 by System Plus Consulting

- SGP40: 4 individual hotplates on freestanding suspended micro-bridges
- Offers the following advantages over SGP30
 - More power-efficient heating
 - Individual temperature profile for each pixel → Sensing conditions can be optimized for the different MOX sensing materials on the 4 pixels



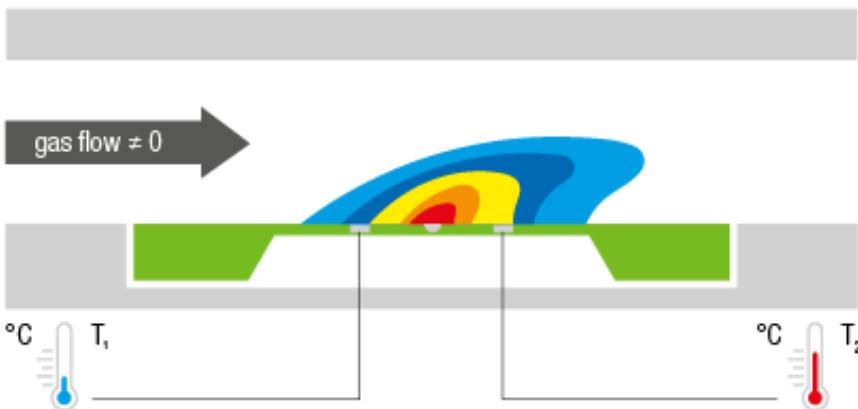
CMOSens example 3: Gasflow sensor chip

SFM3200



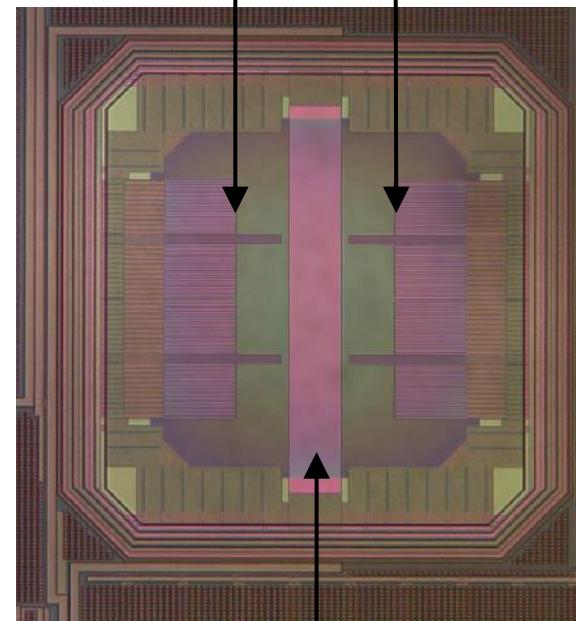
Sensing principle:

Microthermal anemometer



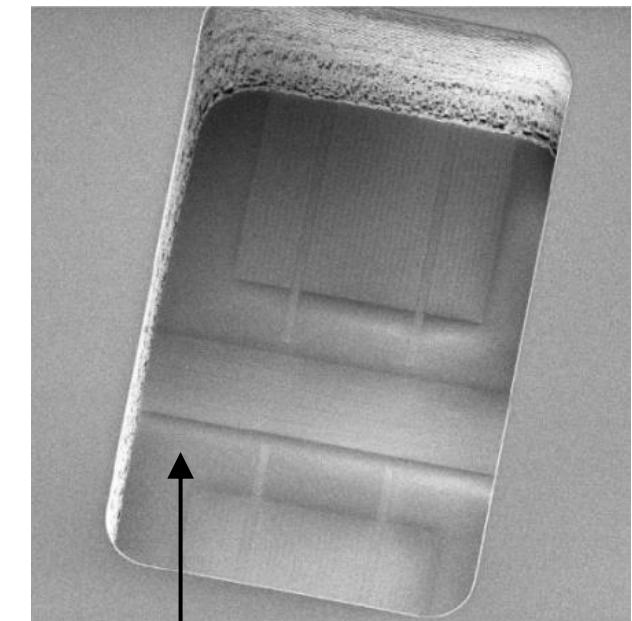
Thermopile T-sensors

Front side



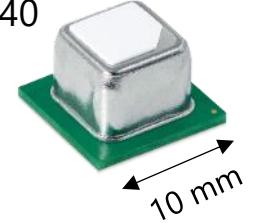
Resistive Heater

Rear side



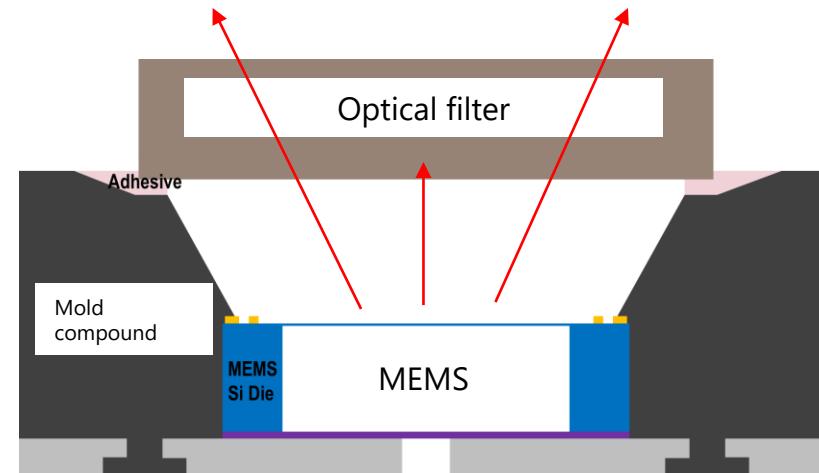
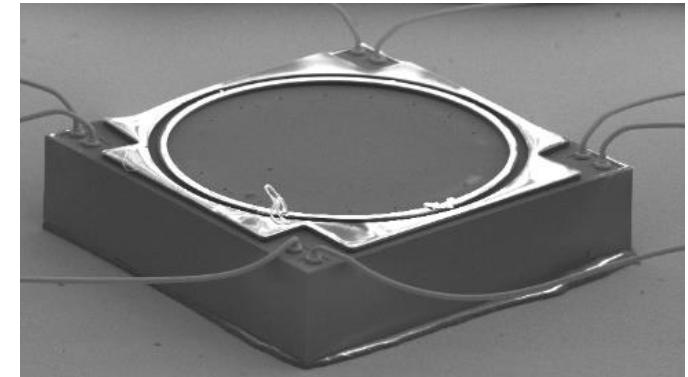
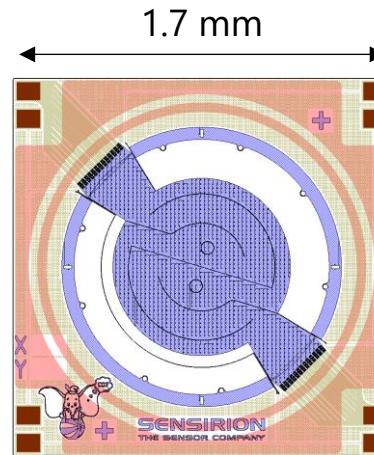
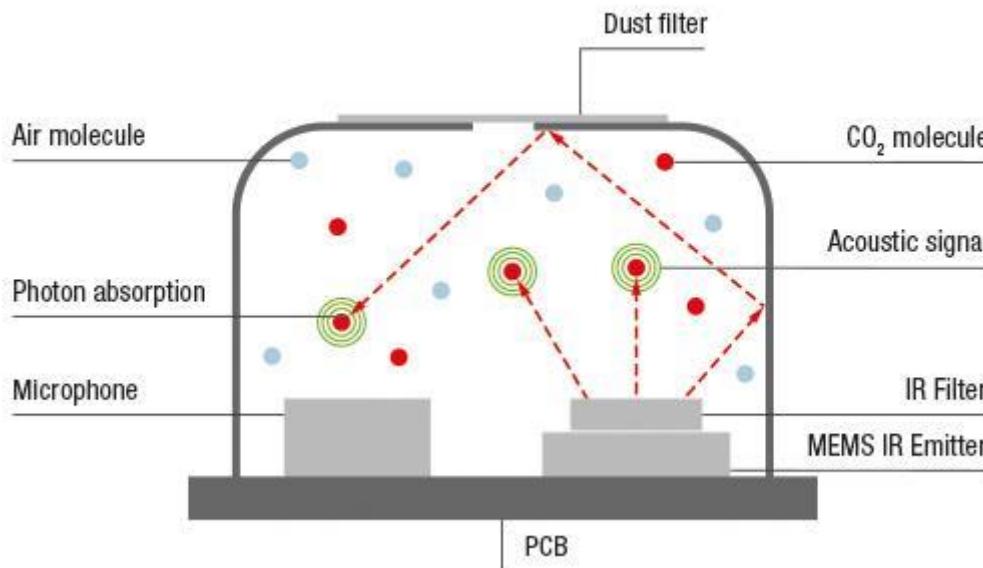
Membrane

SCD40

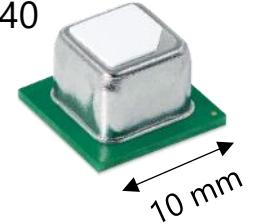


Module example: Miniature CO₂ sensor

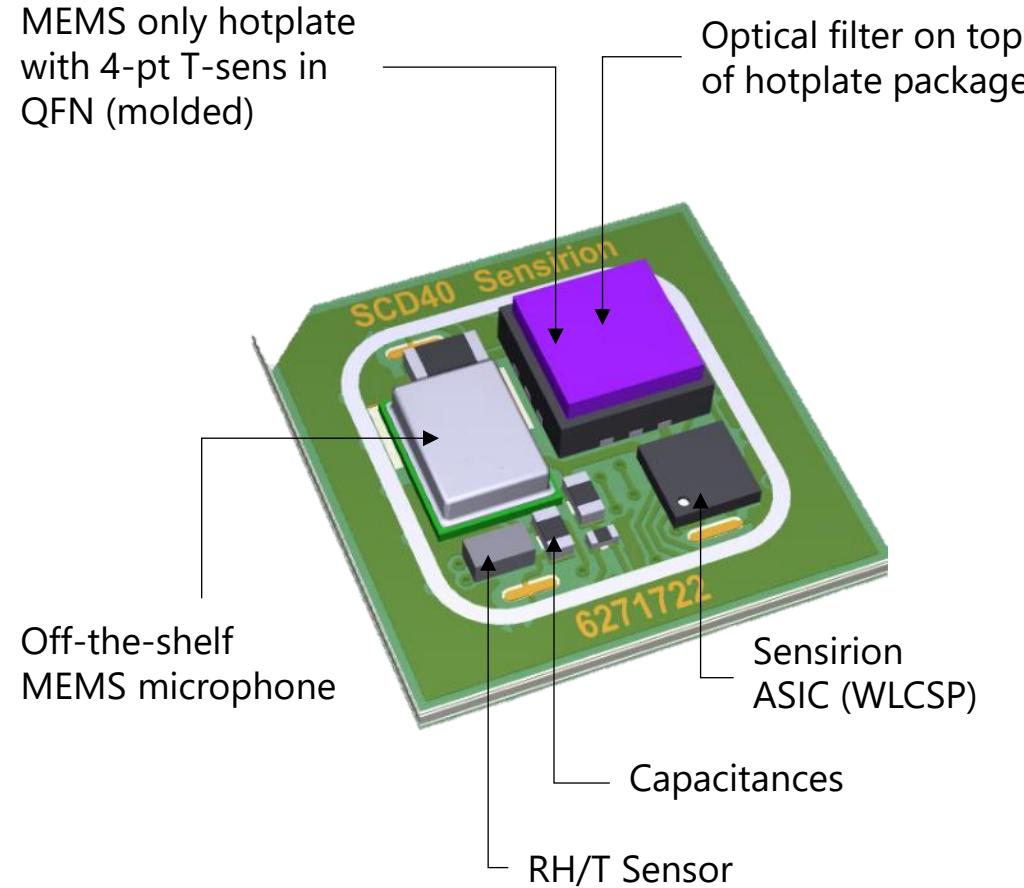
Sensing principle:
Photoacoustic



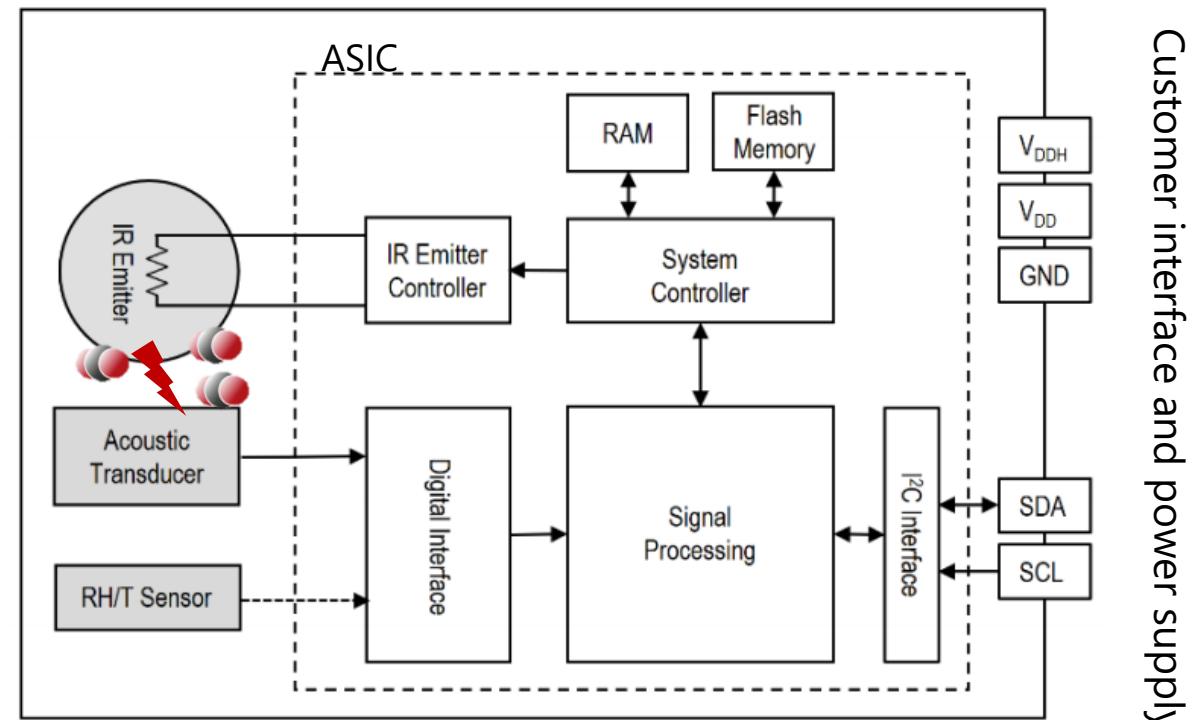
SCD40



Module example: Miniature CO₂ sensor

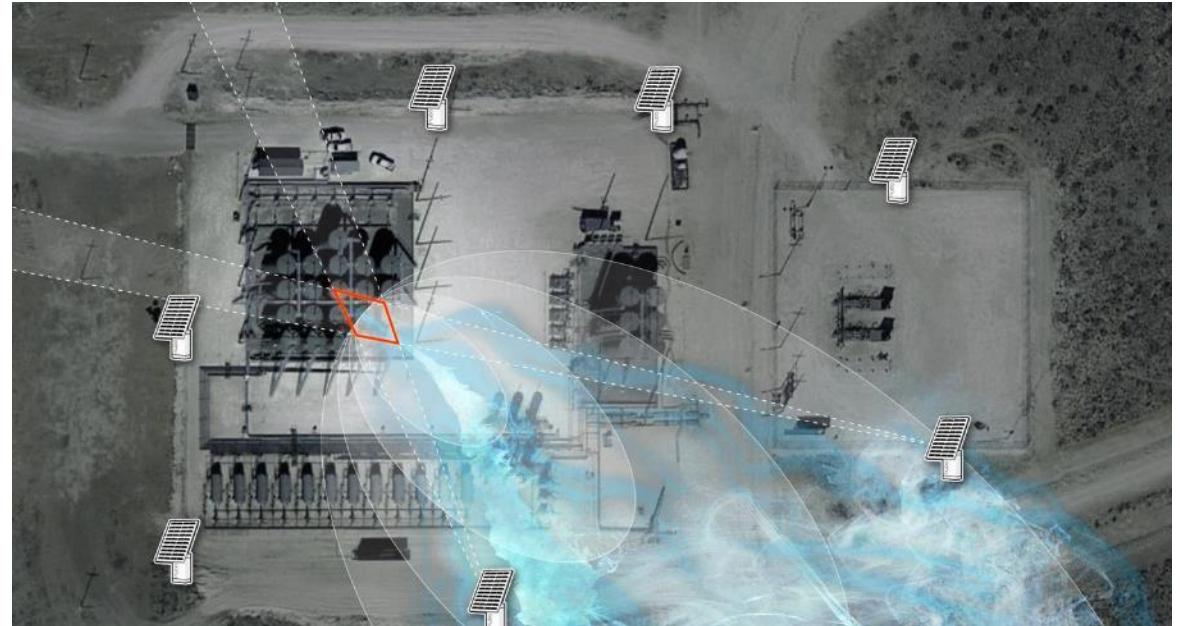
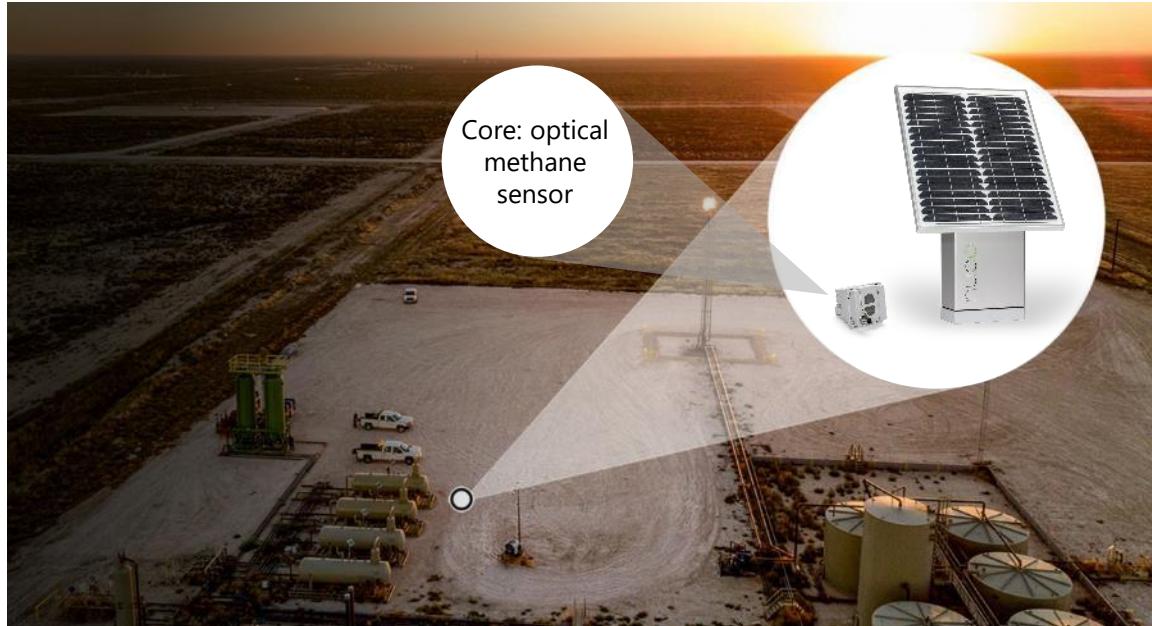


Block diagram SCD40



Full Solution example: Nubo Sphere

End-to-end solution for continuous methane emissions monitoring



Leak detection and repair



Emissions quantification,
reporting and reconciliation



Alerting; Emission localization
and quantification



Continuous monitoring enables
fast reaction time and a
complete picture of emissions

MEMS technology @ Sensirion



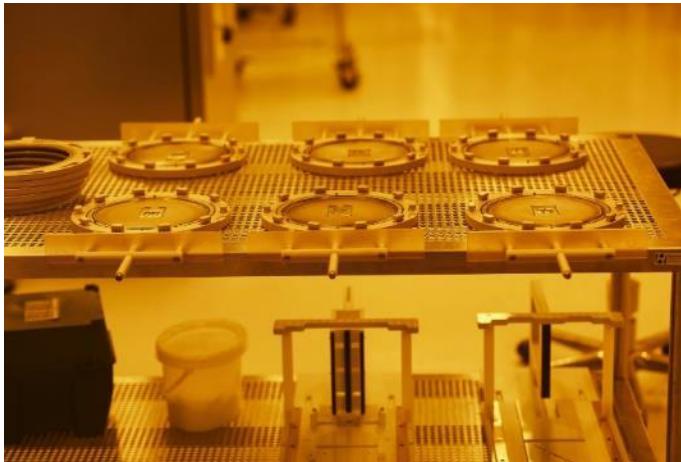
25'000

Wafers per year



1'000 m²

Clean room ISO 6



Feasibility

Design and prototyping

Industrialization

Qualification

Production support

Agenda

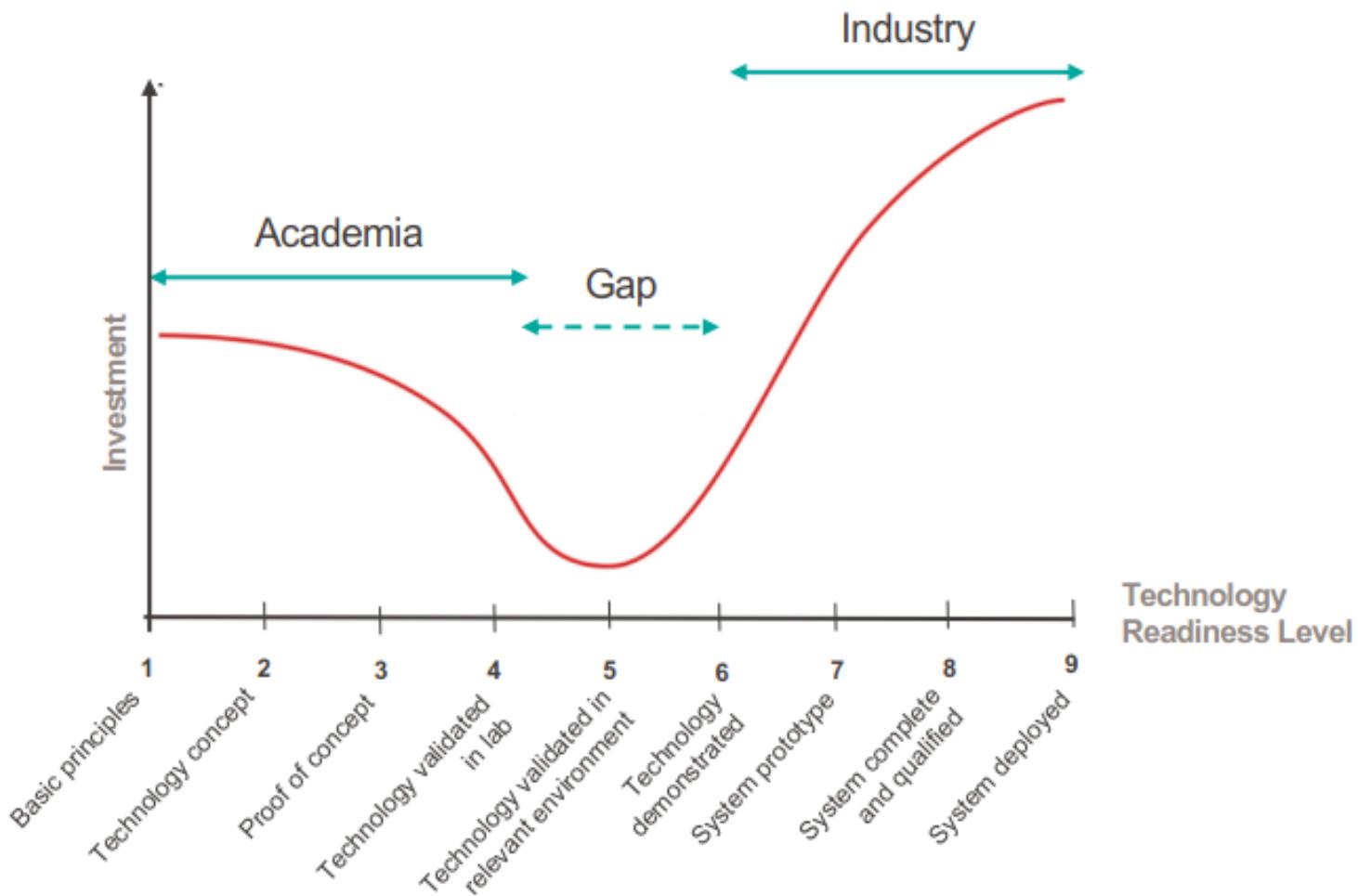
- 1 Sensirion in brief
- 2 Sensirion technology: Some examples
- 3 R&D and innovation in industry



Research in academia

compared to

R&D in industry



Research in academia

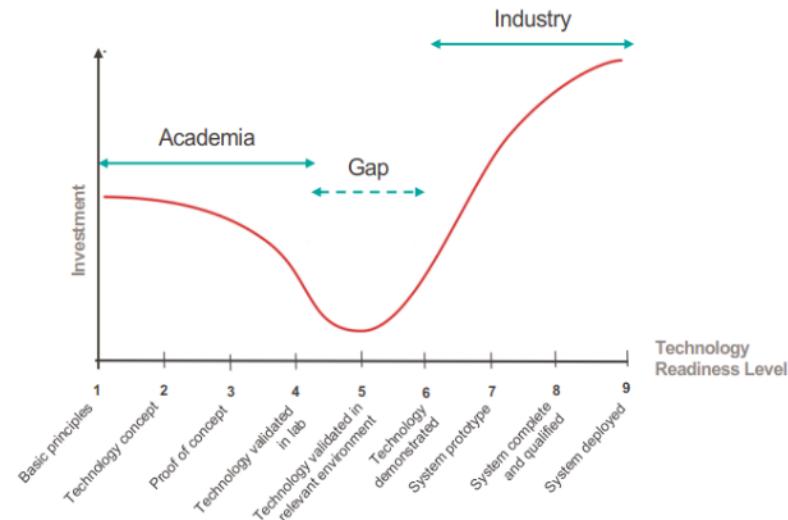
compared to

R&D in industry

- Understand and predict natural phenomena
- Fundamental principles
- **Publications**



- Typ. project size: 4 person years
- Small team
- “World-record” **sensitivity**
- Few samples



- Solve “real-world” problems
- Technology development
- **Product, patents**



(12) United States Patent	(10) Patent No.:	US 8,408,850 B2
Mayer et al.	(45) Date of Patent:	Apr. 2, 2013
(54) METHOD FOR MEASURING A FLUID COMPOSITION PARAMETER BY MEANS OF A TIR SENSOR	(56) 5,985,836 - A	12/19/99
(55) INVENTOR:	(56) 6,007,575 - A	2/2/00
Felix Mayer, 9520 E. Mark	(56) 6,037,223 - A	7/11/00
Herrling, Massachussetts (US)	(56) 6,046,841 - A	4/4/00
Wolff, 2002-03-03	(56) 6,051,874 - A	4/11/00
(53) Appln. Ser. No.:	(56) 6,055,874 - A	4/18/00
Session, 6,454,834 (CH)	(56) 6,062,919 - A	5/2/00
(57) Advisor:	(56) 6,066,210 - A	5/9/00
Session, AG, Suts (CH)	(56) 6,067,165 - A	5/16/00

- Typ. project size: 40+ person years
- Large interdisciplinary teams
- Sensitivity, **selectivity, stability, scalability**
- Millions of sensors → reproducibility is key: Qualification, process control, quality control

SENSIRION